

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.3137	Serial No.	10/658,371
Applicant	Kouji MATSUO		
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date (Pub. date)	Name	Class	Sub Class	Filing Date If Appropriate
one	6,376,888 B1	4/23/2002	Tsunashima et al.			
	6,261,887 B1	7/17/2001	Rodder			
	2003/0143825 A1	(07/31/2003)	Matsuo et al.			
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one	6,483,151	11/19/02	H. Wakabayashi et al.			

FOREIGN PATENT DOCUMENTS						
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
one	2001-203276	7/27/2001	Japan			Yes
one	2000-252370	9/14/2000	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
one	Kouji MATSUO, SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME, U.S. Serial No.: 10/396,453, filed March 26, 2003.
one	Kouji MATSUO et al., "SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME", U.S. Serial No. 09/492,780, filed January 28, 2000.

Examiner	one	Date Considered	1/13/05
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
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